




<b>Issue Classification</b> 	<b>Application/Control No.</b> 10551514	<b>Applicant(s)/Patent Under Reexamination</b> VAN DER WIEL, APPOLONIUS H. JACOBUS	
	<b>Examiner</b> Hsien-ming Lee	<b>Art Unit</b> 2823	

NONE		<b>Total Claims Allowed:</b>	
(Assistant Examiner)	(Date)	12	
/Hsien-ming Lee/ Primary Examiner.Art Unit 2823	11/19/2009	O.G. Print Claim(s)	O.G. Print Figure
(Primary Examiner)	(Date)	1	3 & 4